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|  | METU MEMS CENTERDICING REQUEST FORM |

**Date :**

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| **PERSONAL INFORMATION** |
| Contact Person / Title |  |
| Organization Name |  |
| E-mail |  |
| Phone |  |
| Project Code-Title/ Thesis Title |  |

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| **SAMPLE INFORMATION** |
| **Substrate type** |  |
| **Substrate size** |  |
| **Substrate thickness** (including all added up layers) |  |
| **Number of samples** |  |
| **Ident Nos** (optional) |  |

*Request will not be processed unless the information required above is given in full*

**Comments:**

 Please include the following information as much as possible: Schematic drawing of the sample and cut-lines (please indicate full-depth cuts with thick lines and half-depth cuts with thin lines), center to center spacing of dicing lines, the depth in microns to be left after half-depth cuts, information about alignment and cut-line spacing to structures with a drawing. Please prepare the information for every different sample cutting.

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|  | ODTÜ MEMS MERKEZİKesim İstek Formu**(Örnek)** |

**TARİH :**

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| **KİŞİYE AİT BİLGİLER** |
| İlgili kişi / unvan  | Ali Veli |
| Kurum / Kuruluş Adı | …Üniversitesi, Mak. Müh. Böl. |
| E-posta |  |
| Telefon: |  |
| Proje Kodu-İsmi / Tez Başlığı | TUBİTAK XXXX Kodlu xxxxxx projesi |

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| **ÖRNEK BİLGİSİ** |
| **Taban malzeme tipi** | Cama yapıştırılmış silisyum. |
| **Taban malzeme büyüklüğü** | 100 mm |
| **Taban malzeme kalınlığı**(bütün ilave tabakalar dahil) | 500µm cam+ 100µm silisyum + 10µ fotorezist |
| **Örnek sayısı** | 1 |
| **Sıra No:** (isteğe bağlı) | Xx |

*Yukarıda talep edilen bilgiler eksiksiz verilmediği takdirde talep işleme alınmayacaktır*

**Ek Bilgi:**

